

## PATENT ASSIGNMENT

Electronic Version v1.1  
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Thomas DALIBOR	04/18/2013
RECEIVING PARTY DATA	
Name:	SAINT-GOBAIN GLASS FRANCE
Street Address:	18, avenue d'Alsace
City:	COURBEVOIE
State/Country:	FRANCE
Postal Code:	F-92400
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	13819845
CORRESPONDENCE DATA	
Fax Number:	6267921342
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	626-792-0536
Email:	mail@sbpatlaw.com
Correspondent Name:	Steinfl & Bruno LLP
Address Line 1:	155 N. Lake Ave. Suite 700
Address Line 4:	Pasadena, CALIFORNIA 91101
ATTORNEY DOCKET NUMBER:	P1191-US
NAME OF SUBMITTER:	Thomas Nguyen
Signature:	/Thomas Nguyen, Reg. No. 68,590/
Date:	05/16/2013
Total Attachments: 1 source=1-P1191-US-Signed-Assignment#page1.tif	

OP \$40.00 13819845

PATENT

ASSIGNMENT

I, Thomas DALIBOR, residing in GERMANY with a mailing address at Dillizerstrasse 12a, 82211 HERRSCHING AM AMMERSEE

hereby sell and assign for good and valuable consideration, the receipt of which I hereby acknowledge,

to SAINT-GOBAIN GLASS FRANCE, an entity having its principal place of business in FRANCE at 18, avenue d'Alsace, F-92400 COURBEVOIE,

hereinafter referred to as the assignee, its successors, assigns and nominees, my entire right, title and interest, including all priority rights under U.S. law and/or International conventions and treaties, in and to the "METHOD FOR ANALYSING PHOTOVOLTAIC LAYER SYSTEMS USING THERMOGRAPHY"

invented by me, as described and/or claimed in International Application No. PCT/EP2011/066898, filed on September 28, 2011, in the corresponding U.S. National Phase Patent Application No. 13/819,845, filed on February 28, 2013, and in any other related patent applications filed and/or to be filed not only for, to and in the United States of America its territories and possessions, but also for, to and in all other countries, including any and all divisions, continuations, and continuations-in-part of said International Application PCT/EP2011/066898, and any and all divisions, reissues, continuations, continuations-in-part and extensions of said corresponding U.S. National Phase Patent Application No. 13/819,845, and authorize and request any officials whose duty it is to issue patents, to issue any patent on said "METHOD FOR ANALYSING PHOTOVOLTAIC LAYER SYSTEMS USING THERMOGRAPHY" and/or improvements thereof or resulting therefrom to said assignee or its successors, assigns or nominees, and agree to testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, continuation-in-part and/or reissue applications, make all rightful oaths and/or declarations and generally do everything possible to aid said assignee, its successors, assigns and nominees to obtain and enforce proper patent protection for said invention in the United States of America and in all other countries.

Subscribed and executed at Munich, Germany  
City Country  
On 04/18/2013  
Date

Inventor Name: Thomas DALIBOR  
Inventor Signature Thomas Dalibor

Witnessed by:  
Witness Name: Daniela Glöckle Signature Daniela Glöckle  
Witness Name: Patrick Eraerds Signature P. Eraerds